

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q93721

Hans-Juergen ROSTALSKI, et al.

Appln. No.: 10/571,267

Group Art Unit: 2873

Confirmation No.: 6099

Examiner: Darryl J. COLLINS

Filed: February 12, 2007

For: LITHOGRAPHY LENS SYSTEM AND PROJECTION EXPOSURE SYSTEM  
PROVIDED WITH AT LEAST ONE LITHOGRAPHY LENS SYSTEM OF THIS TYPE

**EXCESS CLAIM FEE PAYMENT LETTER**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

An Amendment Under 37 C.F.R. § 1.111 is attached hereto for concurrent filing in the above-identified application. The resulting excess claim fee has been calculated as shown below:

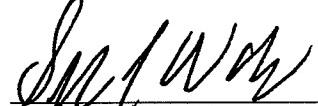
	After Amendment	Highest No. Previously Paid For	
All Claims	24	-	21 = 3 X \$52.00 = \$156.00
Independent	3	-	3 = X \$220.00 = \$.00
		<b>TOTAL</b>	<b>= \$156.00</b>

EXCESS CLAIM FEE PAYMENT LETTER  
U. S. Application No.: 10/571,267

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The USPTO is directed and authorized to charge the statutory fee of \$156.00 and all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account.

Respectfully submitted,



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WASHINGTON OFFICE

23373

CUSTOMER NUMBER

Date: December 1, 2008